

Sheet 1 of 1

Form PTO-1463 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE				ATTY. DOCKET NO. M22-0423		SERIAL NO. 10665 961	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT: Terry L. Gilson		10/695961	
				FILING DATE: October 27, 2003		GROUP: Unknown 2815	
U.S. PATENT DOCUMENTS							
Examin or Index		Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate
MC	AA	6,238,974 B1	05/01	Chem et al.			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes No
	AM						
	AN						
	AO						
	AP						
	AQ						
OTHER REFERENCES (including Author, Title, Date, Patent Pages, Etc.)							
	AR						
	AS						
	AT						
EXAMINER		DATE CONSIDERED					
		Matthew C. Fisher 10/27/04					
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Best Available Copy

12/31/03

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY. DOCKET NO. M113-2428		PRIORITY SERIAL NO. 10177-247		
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)					APPLICANT T. L. Gilson		10/695961		
					PRIORITY FILING DATE June 11, 2003		PRIORITY GROUP 8815		
U.S. PATENT DOCUMENTS									
Examiner Initial	Class	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate		
MCL	AA	6,187,604 B1	2/13/01	Gilson					
	AB								
	AC								
	AD								
	AE								
FOREIGN PATENT DOCUMENTS									
		Document Number	Date	Country	Class	Subclass	Translation		
							Yes	No	
		AM							
		AN							
		AO							
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)									
MCL	AR		Anodic Oxidation of Porous Silicon Layers Formed on Lightly p-Doped Substrates; A. Bieszy et al; pp. 3450-3456; J. Electrochem. Soc. Vol 138, No. 11; November 1991; The Electrochemical Society, Inc.						
MCL	AS		Information and Properties of Porous Silicon Film; Yoshinobu Arita and Yoshio Sunohara; Journal of the Electrochemical Society; Vol. 124, No. 2; February 1977; pp. 285-295						
MCL			Building from the Bottom Up; Nano Technology; October 16, 2000; C & ENR pg. 27-32						
MCL			New Tools for Tiny Jobs; Nano Technology; October 16, 2000; C & ENR pg. 33-35						
MCL			Firms Find a New Field of Dreams; Nano Technology; October 16, 2000; C & ENR pg. 36-38						
MCL	AT		Crafting a National Nanotechnology Effort; Nano Technology; October 16, 2000; C & ENR pg. 39-42						
EXAMINER				DATE CONSIDERED					
Michael C. Fisher				10/27/2004					
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>									

Best Available Copy